Dipankar Chugh

Electronic Materials Engineering Research School of Physics The Australian National University Canberra, ACT, Australia

Email: Dipankar.Chugh@anu.edu.au Telephone: +61 (0) 406 319 610 Citizenship: Australian Country of Birth: India

EDUCATION

July'15 - Jan'20 AUSTRALIAN NATIONAL UNIVERSITY Doctor of Philosophy – Physics Thesis: (MOVPE) Growth and applications of wafer-scale hexagonal boron nitride Developed expertise in the operation of MOVPE/MOCVD reactors and develop process recipes. Optimized epitaxial growth of hexagonal boron nitride (hBN) and aluminum nitride (AlN). Developed proficiency in the use and application of metrology/characterization methods, including XRD, AFM, SEM, photoluminescence and Raman spectroscopy UNIVERSITY OF CALGARY 2006 - 2008Calgary, Canada Master of Science - Electrical Engineering Thesis: Dielectric actuation of liquid and droplets for Lab on a Chip applications Developed a novel technology for manipulating micro/nano-liter sized droplets on planar substrates using electric fields. INDIAN INSTITUTE OF TECHNOLOGY 2002 - 2006Guwahati, India Bachelor of Technology – Biotechnology

EMPLOYMENT HISTORY

Feb'20-ongoing Post-doctoral Research Fellow – Australian National University Canberra, Australia Design and fabricate multi-quantum well, edge-emitting, diode lasers on GaAs substrates. I undertake the following activities: -

- Simulation and design of edge emitting, multi-quantum well laser structures.
- Epitaxial growth optimization of III-Vs (InGaP, InGaAsP, GaAsP and AlGaAs) and (stack) • growth of laser structures.
- Material characterization of epitaxially grown III-V layers.
- Laser device fabrication (including, photomask design, photo-lithography, chemical/plasma etching, wafer thinning and mechanical polishing, metal contact deposition and cleaving laser-diode bars).
- Electrical characterization of diode lasers (threshold current, internal/external quantum efficiency: IQE/EQE).

Microfluidic Technologist - University of South Australia Aug'10 – June'15

- Developed/optimized semiconductor fabrication processes, including deep reactive ion etching of quartz and silicon, UV photolithography, wet chemical etching, physical vapor deposition (metals and dielectrics), plasma/thermal bonding, electroplating.
- Maintained ultra-high vacuum and other fabrication/characterization equipment including • plasma etching, physical vapor deposition and UV photolithography tools.
- Support research and development initiatives at UniSA's Future Industries Institute. Provide training to research students and staff on semiconductor fabrication processes.

Canberra, Australia

Adelaide, Australia

Jan – Dec' 09 Research Assistant – University of Calgary

- Developed proof-of-concept prototypes of microfluidic devices using semiconductor fabrication processes for clinical diagnostic applications.
- The microfluidic devices utilized high frequency electric fields for manipulating sessile micro-droplets containing biomolecules (e.g. fluorophore tagged mRNA molecules) for biochemical analysis.
- Communicate research findings in peer-reviewed journals.

RESEARCH AND ANALYTICAL SKILLS

- Over 10 years of extensive hands-on experience in semiconductor fabrication processes at cleanroom facilities (ISO class 5 and 6) at Australian National Fabrication Facility (ANU and Univ. South Australia); NanoFab (University of Alberta, Canada) and at Advanced Micro/Nanofabrication Integration Facility (University of Calgary, Canada).
- Experience in the growth of compound semiconductor materials (III-Vs) using metal organic vapor phase epitaxy.
- Experience in the design and fabrication of diode laser devices.
- Microfabrication Skills: UV photolithography, physical vapor deposition, plasma enhanced chemical vapor deposition, wet-chemical and plasma etching (III-Vs, silicon, metals and oxides), soft-lithography, hot embossing, wafer bonding, wafer dicing, electroplating.
- Characterization: X-ray diffraction, photoluminescence spectroscopy (steady-state, timeresolved and anti-bunching), atomic force microscopy, scanning electron microscopy (including cathodo luminescence spectroscopy), Raman spectroscopy, interferometry.
- Software: MATLAB, LabVIEW, L-Edit, AutoCAD, Origin, Microsoft Office.

AWARDS AND SCHOLARSHIPS

2015 - 2019	• Australia Postgraduate Award Scholarship (to pursue PhD at ANU)
2019	• Mark Ridgway Travel Scholarship (attend scientific conference in Japan, 2019)
2016	• Winner, EME's Three-Minute Thesis competition
2012	• Frater Award for Staff Development by Australian National Fabrication Facility
2009	MNT Travel and Microfabrication Grants by CMC Microsystems, Canada

ADDITIONAL

- Proficient in design of experiments (DOE), data analysis with hands-on experience in several semiconductor fabrication and characterization techniques.
- Developed collaborations with researchers and scientists at leading Universities in Australia, India, UK and China, leading to joint research publications.
- Published over 15 articles in peer-reviewed journals.
- Presented research work at prominent international scientific conferences in Australia (ICONN-2016, 2020), US (ICNS-2019; ICMOVPE-2018) and Japan (CSW-2019), IEEE 8th International Conference on Photonics (ICP) (2020)
- Invited talks at Malaysia Nitride Research Group 2020 workshop; Nanjing University, China; Hefei University of Technology, China.
- Participated in 3-day workshop on Science Communication by ANU's Center for the Public Awareness of Science in 2018.
- Delivered Three-Minute-Thesis talks at ANU School of Physics' Alumni Meet (Canberra) and The Emerging and Disruptive Technology Assessment Symposium 2017 (Melbourne) organized by the Defense Science and Technology Group, Australia.

LIST OF JOURNAL PUBLICATIONS

- 1. Stern H. et al., Room-temperature optically detected magnetic resonance of single defects in hexagonal boron nitride. https://arxiv.org/abs/2103.16494.
- 2. Mendelson N, **Chugh D** et al, Identifying carbon as the source of visible single-photon emission from hexagonal boron nitride. Nature Materials, 20, 321–328 (2021).
- 3. Raj V, **Chugh D**, et al, Passivation of InP Solar Cells Using Large Area hexagonal-BN Layers. NPJ 2D Materials and Applications 5, 12 (2021).
- 4. Bera K, Roy A, **Chugh D**, Wong-Leung J, Tan H and Jagadish C, Role of defects and grain boundaries in the thermal response of wafer-scale hBN films. Nanotechnology 32 075702.
- 5. **Chugh D**, Adhikari S et al, Improving the Morphology and Crystal Quality of AlN Grown on Two-Dimensional hBN. Crystal Growth & Design 20, 3(2020) 1811-1819.
- 6. Bera J, Chugh D, et al, Strain distribution in wrinkled hBN films. Solid State Communications 310 (2020).
- 7. **Chugh D**, Jagadish C, Tan H. Large-Area Hexagonal Boron Nitride for Surface Enhanced Raman Spectroscopy. Advanced Materials Technologies 4, 1-7 (2019).
- 8. **Chugh D**, Wong-Leung J, Li L, Lysevych M, Tan H, Jagadish C Flow modulation epitaxy of hexagonal boron nitride. 2D Materials 5, 4(2018) 1-10.
- Ghediya P, Chaudhuri T, Raj V, Chugh D, Vora K, Li L, Tan H, Jagadish C. Direct-coated Cu2SnS3 films from molecular solution inks for solar photovoltaics. Materials Science in Semiconductor Processing 88(2018) 120-126.
- Duong T, Peng J, Walter D, Xiang J, Shen H, Chugh D, Lockrey M, Zhong D, Li J, Weber K, White T, Catchpole K. Perovskite Solar Cells Employing Copper Phthalocyanine Hole-Transport Material with an Efficiency over 20% and Excellent Thermal Stability. ACS Energy Letters 3, 10(2018) 2441-2448.
- 11. Elmas S, Ambroz F, **Chugh D**, Nann Thomas, Microfluidic Chip for the Photocatalytic Production of Active Chlorine, Langmuir, 32 (19), pp 4952–4958
- 12. Kaler K., Prakash R. and **Chugh D**. Liquid dielectrophoresis and surface microfluidics. Biomicrofluidics 4, 022805 (2010).
- 13. **Chugh D** and Kaler, K (2009). Integrated Liquid and Droplet Dielectrophoresis for Biochemical Assays. Journal of Microfluidics and Nanofluidics, DOI. 10.1007/s10404-009-0469-7.
- 14. **Chugh D** and Kaler K, (2008). Leveraging Liquid Dielectrophoresis for Microfluidic Application. Biomedical Materials 3, pp. 034009.
- 15. Pakshirajan K, Chugh D and Saravanan P, (2008). Feasibility of m-cresol degradation using an indigenous mixed microbial culture with glucose as a co-substrate. J. of Clean Tech. and Environ. Policy 10, pp. 303-308.
- 16. Wijngaart W, **Chugh D**, Man E, Melin J and Stemme G, (2007). A Low-Temperature Thermopneumatic Actuation Princliple for Gas Bubble Microvalves. J. of MEMS 16, pp. 765.
- Halder K, Mathur V, Chugh D, Verma A and Chowdhury S, (2005). Quadruplex-Duplex competition in the Nuclease Hypersensitive Element of Human c-myc Promoter: C to T mutation in C-rich strand enhances Duplex Association. BBRC 327, page 49-56.

PATENTS/TECHNOLOGY DISCLOSURE

1. Controlled Dispensing of Ultrafine, Variable Volume, Emulsion Droplets, Karan V.I.S. Kaler, Ravi Prakash and **Dipankar Chugh**, Pub. No.: US 2012/0006681 A1, Pub. Date: Jan. 12th, 2012.

REFERENCES

Prof. Hoe Tan Director: Australian National Fabrication Facility, ACT Node Research School of Physics The Australian National University Email: Hoe.Tan@anu.edu.au; Tel: (+61) 02 6125 0356 Relation: Current principal supervisor (and Ph.D. supervisor)

Prof. Chennupati Jagadish Research School of Physics The Australian National University Email: Chennupati.Jagadish@anu.edu.au ; Tel: (+61) 02 6125 0363 Relation: Associate supervisor (Ph.D.)

A/Prof. Jennifer Wong-Leung Research School of Physics The Australian National University Email: jenny.wongleung@anu.edu.au; Tel: (+61) 02 6125 0360 Relation: Associate supervisor (Ph.D.)

Mr. Simon Doe Facility Manager: Australian National Fabrication Facility, SA Node Future Industries Institute, University of South Australia Email: Simon.Doe@unisa.edu.au; Tel: (+61) 08 8302 5226 Relation: (previous) Line Manager, ANFF-SA (between 2010-2015)